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APPLICANTS

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** CONTINUING DATA *****

None dm

** FOREIGN APPLICATIONS *****

JAPAN 2002-240891 08/21/2002
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 JAPAN 2002-346179 11/28/2002

dm

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	14	60	9
Verified and Acknowledged	<i>dm</i>	Initials			

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TITLE

Substrate processing apparatus and substrate processing method

<input type="checkbox"/> All Fees
<input checked="" type="checkbox"/> 1.16 Fees (Filing)